IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaichi MURAKAMI et al.

Group Art Unit: 2851

Application No.: 09/772,907

Examiner:

A. Mathews

Filed: January 31, 2001

Docket No.: 108483

For:

SCANNING EXPOSURE METHOD AND SYSTEM

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the November 13, 2003 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims;

Amendments to the Drawings include an attached replacement sheet; and

Remarks.